

In re the Application of

Aarne HEINO

Application No.: U.S. National Stage of PCT/FI99/00570

Filed: December 7, 2001

Docket No.: 111389

For: METHOD IN CONNECTION WITH PROCESSING POLYMER OR ELASTOMER MATERIAL

INFORMATION DISCLOSURE STATEMENT

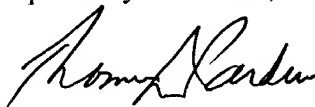
Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully submitted,



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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 111389		APPLICATION NO. U.S. National Stage of PCT/FI99/00570	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Aarne HEINO			
				FILING DATE December 7, 2001			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
SML		4,738,868	04-19-1988	Fischer et al.			
SML		4,894,284	01-16-1990	Yamanouchi et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
SML		JP 59-099611 A2 (abstract only)	11-30-1982	Japan	/	/	
↑		JP 61-92459 (abstract only)	07-12-1994	Japan	/	/	
↓		GB 2 283 489 A	05-10-1995	United Kingdom	/	/	
SML		WO 97/10936 A2	03-27-1997	WIPO	/	/	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							